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**INDUSTRY STANDARD OF THE
PEOPLE'S REPUBLIC OF CHINA**

JB/T 12067-2014

TDL-GX Silicon Core Growing Furnace

TDL-GX 硅芯生长炉

(English Translation)

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2 Normative references

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JB/T 12067-2014 cites the following standards, which apply in full or in part through the references made to them in its clauses.

GB 150-2011

GB/T 2900.23-2008

GB/T 10066.1-2004

GB/T 10066.4-2004

GB/T 10067.1-2005

GB/T 10067.4-2005